

Notice of References Cited

Applicant/Patent

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Application/Control No.

09/550,405

Examiner

ORI NADAV

Art Unit

2811

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	Document Number Country Code-Number-Kind Code	Date MM-YYYY ¹	Name	Classification ²	
A	5,316,977	5/1994	Kunishima et al.	437	200
B	5,545,575	8/1996	Cheng et al.	437	40
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NON-PATENT DOCUMENTS

	Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
U	CMOS structure with trench isolation, IBM Technical Disclosure Bulletin, 10/1984, US, Vol. 27, issue 5, page 3045.
V	
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^{*} A copy of this reference is not being furnished with this Office action. See MPEP § 707.05(a).¹ Dates in MM-YYYY format are publication dates.² Classifications may be U.S. or foreign.